

**INFORMATION  
DISCLOSURE  
STATEMENT**

Atty. Docket No.: P-7322

Serial No.: 09/017-194

Applicant(s): Markus Haller et al.

Filing Date: February 2, 1998

Group: 3734


**U.S. PATENT DOCUMENTS**

Examiner Initial		Document Number	Date	Name	Class	SubClass	Filing Date if Appropriate
<i>SS</i>	AA	4,129,042	12/12/78	Rosvold	73	727	11/18/77
	AB	5,163,920	11/17/92	Olive	604	247	01/30/91
	AC	5,171,132	12/15/92	Miyazaki et al.	417	413	12/21/90
	AD	5,189,777	03/02/93	Guckel et al.	29	424	12/07/90
	AE	5,199,303	04/06/93	Benedikt et al.	73	727	07/05/91
	AF	5,271,724	12/21/93	van Lintel	417	413A	
	AG	5,357,807	10/25/94	Guckel et al.	73	721	10/05/92
	AH	5,377,524	01/03/95	Wise et al.	73	4 R	06/22/92
	AI	5,447,067	09/05/95	Biebl et al.	73	514.32	03/08/94
	AJ	5,585,011	12/17/96	Saaski et al.	216	2	05/19/95

**FOREIGN PATENT DOCUMENTS**

		Document Number	Date	Country	Class	SubClass	Translation	
							Yes	No
	AA	EP 0 368 446	05/16/90	United Kingdom	G01P	15/12		
	AB	EP 0 542 719	05/19/93	United Kingdom	G01P	21/00		
	AC	EP 0 606 115	07/13/94	Germany	G01D	18/00	X	

**OTHER DOCUMENTS (Including Authors, Title, Date, Pertinent Papers, etc.)**

			"Microflow Devices and Systems" - J. Micromech. Microeng. 4 (1994) 157-171 - S. Sheji and M. Esashi					

EXAMINER

Date Considered

6/11/03

\*Examiner: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.